

Atty. Dkt. No. 023312-0109

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE 7056446

Applicant:

Takashi NAGASE et. al.

Title:

METHOD OF MANUFACTURING NANO-

**GAP ELECTRODE** 

Appl. No.:

10/662,886

Filing Date:

9/16/2003

Examiner:

Ahmed, Shamim

Art Unit:

1765

PETITION TO CORRECT ASSIGNEE ON PTOL-85 UNDER 37 C.F.R. § 1.183

Mail Stop Issue Fee Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 RECEIVED

MAY 0 4 2006

OFFICE OF PETITIONS

Sir:

Applicants respectfully request that under 37 C.F.R. §1.183, the assignee shown incorrectly on the Issue Fee Transmittal, PTO-85, be corrected in the above-identified application prior to issuance of the patent.

Applicants hereby state that the incorrect assignee's name shown on Form PTOL-85, box 3A, was inadvertent. The change of name from Communications Research Laboratory, Independent Administrative Institution to National Institute of Information and Communications Technology, Incorporated Administrative Agency was recorded December 5, 2005, at Reel 017090, Frame 0580 (prior to payment of the Issue Fee). It is respectfully requested that the correct and current Assignee be shown on the face of the patent to issue in this application as follows.

"National Institute of Information and Communications Technology, Incorporated Administrative Agency; Tokyo, Japan."

A credit card authorization form to cover the petition fee of \$400.00 is enclosed. Issuance of the patent on the above-identified application with the correct Assignee as outlined above is solicited.

The Commissioner is hereby authorized to charge any additional fees which may be required regarding this application or credit any overpayment, to Deposit Account No. 19-0741.

Respectfully submitted,

Date

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